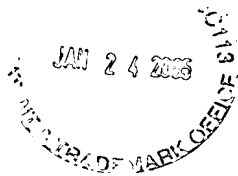


Docket No.: Z&PINFN10309



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/616,396
Applicant : Matthias Goldbach, et al.
Filed : July 9, 2003
Title : Method for Fabricating Trench Capacitors for Integrated
Semiconductor Memories
Docket No. : Z&PINFN10309
Customer No. : 24131

STATUS LETTER

Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

It is respectfully requested that this Status Letter be returned to:

LERNER AND GREENBERG, P.A.
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101

with an indication as to when an action may be expected.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Alexia J. Vrahimis", written over a horizontal line.

Alexia J. Vrahimis

Date: January 18, 2005

/av